

AF / IFW

## AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Dong-Bock LEE

Docket No.

SEC.1043

Application No. 10/697,032	Filing Date October 31, 2003	Examiner Luz L. Alejandro Mulero	Customer No. 20987	Group Art Unit 1763	Confirmation No. 1092
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Invention: CHAMBER STRUCTURE IN INDUCTIVE COUPLING PLASMA ETCHING APPARATUS

COMMISSIONER FOR PATENTS:

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

## CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	13 -	20 =	0	x \$50.00	\$0.00
INDEP. CLAIMS	3 -	3 =	0	x \$200.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

No additional fee is required for amendment.

Please charge Deposit Account No. in the amount of

A check in the amount of to cover the filing fee is enclosed.

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Any additional filing fees required under 37 C.F.R. 1.16.

Any patent application processing fees under 37 CFR 1.17.

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Signature

Dated: May 3, 2005

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CC:



Application No. 10/697,032  
SEC.1043  
Amendment dated: May 3, 2005

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

:

Dong-Bock Lee

: Group Art Unit: 1763

Application No. 10/697,032

: Examiner: Alejandro Mulero, Luz L.

Filed: October 31, 2003

:

CHAMBER STRUCTURE IN INDUCTIVE COUPLING PLASMA ETCHING APPARATUS

**AMENDMENT AND REQUEST FOR  
RECONSIDERATION AFTER FINAL**

U.S. Patent and Trademark Office  
**Customer Window, Mail Stop AF**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

In response to the Office Action dated March 18, 2005, the Applicants submit the following claims amendment, and remarks and arguments regarding the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.